



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.  
Serial No.: 10/640,850  
Filed: August 13, 2003  
For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS  
Group Art Unit: 1742  
Examiner: H. D. Wilkins III  
Attorney Docket: MURT P083D1

**CERTIFICATE OF MAILING**

Date of Deposit: September 7, 2006

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**AMENDMENT "B" AFTER FINAL ACTION**

Mail Stop AF  
Commissioner for Patents  
Alexandria, Virginia 22313-1450

Sir:

In response to the Final Office Action dated July 10, 2006 in the above-referenced application, applicant further amends the application as follows:

*Do not Enter  
Henry Will*